

Application No. 10/586,593
Paper Dated: March 6, 2009
In Reply to USPTO Correspondence of February 9, 2009
Attorney Docket No. 4605-062147

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/586,593 Confirmation No. 1650
Applicant : MASATAKA NAKAHARA et al.
Filed : July 19, 2006
Title : POLISHING METHOD AND POLISHING FILM
FOR USE IN THE POLISHING METHOD
Group Art Unit : 1793
Examiner : Michael A. Marcheschi
Customer No. : 28289

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

Applicants hereby respond to the Office Action dated February 9, 2009, in connection with the above-identified application.

The Examiner has requested election and restriction between Group I, including claims 1-4, covering a method of polishing; Group II, including claims 5-15, covering a polishing film; and Group III, including claims 16-17, covering a method of making a polishing film. Applicants elect to prosecute the claims of Group II and reserve the right to file a divisional application or take such other appropriate measure as they deem necessary to protect their inventions lying within Groups I and III.

I hereby certify that this correspondence is being electronically submitted to the United States Patent and Trademark Office on March 6, 2009.

03/06/2009
Date

Signature

Christine P. Marney

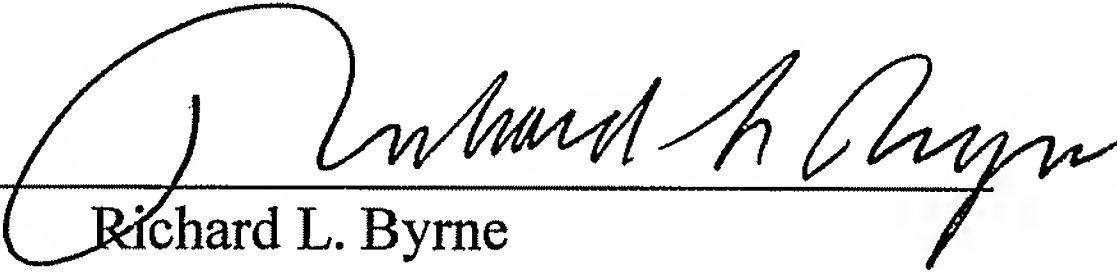
Typed Name of Person Signing Certificate

Application No. 10/586,593
Paper Dated: March 6, 2009
In Reply to USPTO Correspondence of February 9, 2009
Attorney Docket No. 4605-062147

Examination and allowance of claims 5-15 are respectfully requested.

Respectfully submitted,

THE WEBB LAW FIRM

By 

Richard L. Byrne
Registration No. 28498
Attorney for Applicants
436 Seventh Avenue
700 Koppers Building
Pittsburgh, PA 15219
Telephone: (412) 471-8815
Facsimile: (412) 471-4094
E-mail: webblaw@webblaw.com